



OCKET NO: 198786US-2RE

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

MITSUHIRO YANO, ET AL.

: EXAMINER: CRANE, SARA W.

SERIAL NO: 09/891,925

:

FILED: JUNE 27, 2001

: GROUP ART UNIT: 2811

FOR: SEMICONDUCTOR DEVICE AND
METHOD OF FABRICATING SAME

RESPONSE

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of April 4, 2007, favorable reconsideration of this application, in view of the present response is respectfully requested.

Remarks begin on page 2 of this paper.